



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of	)	Confirmation No. 7016
	)	
ICHIMURA et al	)	Examiner: JOHNSON, Connie P.
	)	
Serial No.: 10/520,106	)	Art Unit: 1752
	)	
Filed: January 3, 2005	)	

For: ACTIVE RAY SENSITIVE RESIN COMPOSITION, ACTIVE ENERGY RAY  
SENSITIVE FILM AND METHOD FOR FORMING PATTERN USING THE FILM

AMENDMENT & RESPONSE TO OFFICE ACTION OF MARCH 8, 2007

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please amend the captioned application as follows: